SHEET 1 OF 1

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LIST OF REFERENCES CITED BY APPLICANT				Akira NISHIYAMA			t, or all		
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)									
A.M	AW	L. D. Zhang, et al., "Dielectric Behaviour of Nano-TiO <sub>2</sub> Bulks", phys. stat. sol. (a) 157, 483, 1996, pgs. 483-491							
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*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									